

Notice of References Cited	Application/Control No. 09/975,419		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Andrew C. Lee		Art Unit 2616	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,868,075	03-2005	Narvinger et al.	370/335
*	B	US-6,442,193	08-2002	Hirsch, Olaf Josef	375/147
*	C	US-6,970,438	11-2005	Mate et al.	370/329
*	D	US-2002/0141331	10-2002	Mate et al.	370/218
*	E	US-2002/0009061	01-2002	Willenegger, Serge	370/328
*	F	US-6,904,076	06-2005	Tsutsui et al.	375/130
*	G	US-6,115,406	09-2000	Mesecher, David K.	375/130
*	H	US-6,205,166	03-2001	Maruta et al.	375/130
*	I	US-6,816,717	11-2004	Sipila, Kari	455/277.2
*	J	US-6,714,584	03-2004	Ishii et al.	375/148
*	K	US-6,333,926	12-2001	Van Heeswyk et al.	370/335
*	L	US-6,724,828	04-2004	Dabak, Anand G.	375/267
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.